



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2828
Koichiro TANAKA	)	Examiner: A. Rodriguez
Serial No. 09/481,396 Filed: January 12, 2000	) )	CERTIFICATE OF MAILING  I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 22-04  Adulm Stanfer
For: LASER IRRADIATION APPRATUS	)	

## <u>AMENDMENT</u>

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated April 22, 2004, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.